

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Tomokazu KAWAMOTO Group Art Unit: 2812

Serial No.: 10/673,565 Examiner: Not yet assigned

Filed: September 30, 2003 Confirmation No.: 6423

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

Attorney Docket No.: 031731 Customer Number: 38834

# INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

January 13, 2004

Sir:

Applicants direct the attention of the Patent and Trademark Office to the documents listed on the attached Form PTO-1449. A copy of each listed document is attached.

No fee or certification is required in connection with this Information Disclosure Statement, because it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. Applicants respectfully request that the information be expressly considered during the prosecution of this application and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee that is required to effect consideration of this statement.

Respectfully submitted,

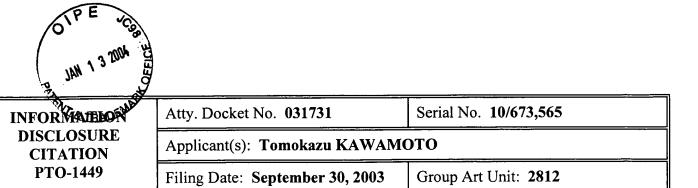
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Enclosures: Form PTO-1449 & 5 References

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## **U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD						
	AE						

#### FOREIGN PATENT DOCUMENTS

<u></u>	Document No.	Date	Country	Translation (Yes or No)
AF	7-272990	10/20/1995	Japan	Yes (Abstract)
AG	2000-277449	10/06/2000	Japan	Yes (Abstract)
AH	2001-7220	01/12/2001	Japan	Yes (Abstract)
ΑI	2001-297996	10/26/2001	Japan	Yes (Abstract)
AJ	2000-114197	04/21/2000	Japan	Yes (Abstract)

## **OTHER DOCUMENTS**

	AK AL	
Examiner		Date Considered